

LIST OF ART CITED BY APPLICANT (PTO-1449)		ATTY. DOCKET NO. <i>P E</i> 521.41463X00 (888-0034)	SERIAL NO. 092925,626
		APPLICANT Oka et al.	FEB 12 2003 PATENT & TRADEMARK OFFICE
		FILING DATE August 10, 2001	GROUP 2811

U.S. PATENT DOCUMENTS

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TECHNOLOGY CENTER 23000

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
<i>JKC</i>	09-82997	3/28/97	Japan			Abstract	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

 Yamamoto et al. Central Research Laboratories, Kaneka Corporation, Japan "Thin-Film Polycrystalline Si Solar Cell on Glass Substrate Fabricated by a Novel Low Temperature Process" IEEE, December 5-9, 1994, ppgs. 1575-1578

EXAMINER <i>Shemayoff</i>	DATE CONSIDERED 5/20/03
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.